

Inventor: Jane Buehler

Title: Methods of Treating Physical Vapor Deposition Targets

Assignee: Honeywell International, Inc.

Attorney Docket No. HO001499-DIV1

jc971 U.S. PTO
10/08/1757
02/19/02

INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a divisional application of co-pending application Serial No. 09/687,947, filed October 13, 2000. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Dated:

2/19/02

Respectfully submitted,



David G. Latwesen, Ph.D.
Reg. No. 38,533

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. HO001499-DIV1		Priority SERIAL NO. 09/687,947			
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT J. Buehler					
				Priority FILING DATE October 13, 2000		Priority GROUP 1753			
U.S. PATENT DOCUMENTS									
*Examiner Initial		Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate	
	AA	3,630,881	12/71	Lester et al.					
	AB	3,985,635	10/76	Adam et al.					
	AC	4,551,216	11/85	Argyo					
	AD	5,336,386	08/94	Marx et al.					
	AE	5,538,603	07/96	Guo					
	AF	5,658,442	08/97	Van Gogh et al.					
	AG	5,753,090	05/98	Obinata					
	AH	6,086,735	07/00	Gilman et al.					
	AI	5,632,869	05/97	Hurwitt et al.					
	AJ	5,282,943	02/94	Lannutti et al.					
	AK								
	AL								
FOREIGN PATENT DOCUMENTS									
		Document Number	Date	Country		Class	Subclass	Translation	
								Yes	No
	AM	06 306597	11/94	Japan					
	AN								
	AO								
	AP								
	AQ								
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)									
	AR								
	AS								
	AT								
EXAMINER				DATE CONSIDERED					
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>									

10/08/17
10/19/02